

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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Title of Invention

METHOD OF FABRICATING POLY-CRYSTAL ITO FILM AND
POLYCRYSTAL ITO ELECTRODE

Application Number : 10/711 864
Confirmation Number: 10/11/04
First Named Applicant: Fang-An Shu
Attorney Docket Number: 14150-US-PA
Art Unit:
Examiner:
Search string: (6448158 or 6218310).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
TN	1	6448158	2002-09-10	Chih-Yu Peng	B2	438	487
TN	2	6218310	2001-04-17	Lewis Shen	B1	438	714

Signature

Examiner Name	Date
	9/14/05